507051380 12/29/2021

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT7098218

NATURE OF CONVEYANCE: ASSIGNMENT OF PATENT OWNERSHIP OF SIARGO LTD. TO SIARGO, INC. M-TECH INSTRUMENT CORPORATION (HOLDING) LIMITED STILL KEPT 50% RIGHTS OF THE WHOLE PATENT	SUBMISSION TYPE:	NEW ASSIGNMENT
OWNERSHIP.		SIARGO, INC. M-TECH INSTRUMENT CORPORATION (HOLDING) LIMITED STILL KEPT 50% RIGHTS OF THE WHOLE PATENT

CONVEYING PARTY DATA

Name	Execution Date
SIARGO LTD.	12/29/2021

RECEIVING PARTY DATA

Name: SIARGO, INC.	
Street Address:	3100 DE LA CRUZ BLVD. SUITE 210
City:	SANTA CLARA
State/Country:	CALIFORNIA
Postal Code:	95054

PROPERTY NUMBERS Total: 1

Property Type	Number	
Patent Number:	7765679	

CORRESPONDENCE DATA

Fax Number: (408)969-0368

Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

Phone: 4088198917

Email: cchen@siargo.com
Correspondent Name: CHIH-CHANG CHEN

Address Line 1: 3100 DE LA CRUZ BLVD. SUITE 210
Address Line 4: SANTA CLARA, CALIFORNIA 95054

NAME OF SUBMITTER: CHIH-CHANG CHEN	
SIGNATURE:	/Chih-Chang Chen/
DATE SIGNED:	12/29/2021

Total Attachments: 2

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PATENT 507051380 REEL: 058599 FRAME: 0916

UTILITY PATENT ASSIGNMENT

FOR VALUE RECEIVED, the receipt of	f which is hereby acknowledged, the following
entity (hereinafter called "ASSIGNOR")	

Name: Siargo Ltd.

Address: 3100 De La Cruz Boulevard, Suite 210, Santa Clara, CA 95054, USA

hereby agrees to transfer and assign its rights and interest in the patent to:

Name: **Siargo, Inc.**

Address: 3100 De La Cruz Boulevard, Suite 210, Santa Clara, CA 95054, USA

(hereinafter called "ASSIGNEE"), the entire worldwide right, title and interest in and to the invention known as:

for which a United States Patent was filed on even date herewith or, if not so, was

filed on September 19, 2006

Patent No. <u>7765679</u>

Tilte: Method of manufacturing a flow rate sensor

PATENT REEL: 058599 FRAME: 0917 and all rights and privileges under any Letters Patent which may be granted thereon, including all rights, if any, to sue for past infringement.

- (1) The ASSIGNOR agrees without charge to said ASSIGNEE but at its expense (a) to execute (i) all necessary papers to be used in connection with this application and any additional, continuing, or divisional applications, as the ASSIGNEE may deem necessary or expedient, (ii) all papers in connection with any interference or other legal or quasi-legal proceedings relating to this application or any additional, continuing, or divisional application thereof; (b) to cooperate with ASSIGNEE in every way possible in obtaining evidence and going forward in any such proceedings; and (c) to perform all other affirmative acts which may be necessary or desirable to obtain a grant of a valid patent for said invention.
- (2) ASSIGNOR hereby authorizes and requests the Commissioner of Patents and Trademarks of the United States to issue any and all Letters Patent that may be granted upon any patent application or any additional, continuing or divisional applications thereof to the ASSIGNEE, its successors and assigns.
- (3) ASSIGNOR hereby covenants and warrants that he has full right to convey the entire right, title and interest by this instrument, free of any encumbrances and that no other agreement has been or will be executed in conflict herewith.

			Par. 4
Date _	Dec. 29, 2021	Signature	

RECORDED: 12/29/2021

PATENT REEL: 058599 FRAME: 0918